				Attorn	ey Docket Number	4641-59261	
,				Application Number		09/881,445	
INFORMATION DISCLOSURE STATEMENT				Filing Date		June 13, 2001	
O P E BY APPLICANT				First Named Inventor		Ushio	
AUG 0 8 2003 2				Art Unit		2818	
(AUG U B	WW 72			Examiner Name		Not yet assigned	
FRAI & TRAI	DEMARKER	U.S. PA	ATENT DO	CUME	NTS		
Examiner's Initials*	Cite No. (optional)	Number	Date		Name		
MB		4,645,349	Feb. 24, 19	87	Tabata		
MA		4,744,660	May 17, 19	88	Noguchi et al.		
M		5,696, 583	Dec. 9, 199	7	Yoon		
M		5,893,796	Apr. 13, 1999		Birang et al.		
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M		6,280,290 B1	Aug. 28, 2001		Birang et al.		
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M		6,537,133 B1	Mar. 25, 2003		Birang et al.		
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Examiner's Initials*	Cite No. (optional)	Number	Date	;	Country		
M		56-153207	Nov. 27, 19	981	Japan (w/English a	abstract)	
Mo		60-305	Jan. 5, 1985	5	Japan (w/English translation of relevant part)		
M		61-76904	April 19, 19	986	Japan (corresponds to US 4,645,349)		
MB		61-235708	Oct. 21, 19	86	Japan (corresponds to US 4,744,660)		
M		63-50703	March 3, 19	988	Japan (w/English translation of relevant part)		
M		64-57107	March 3, 19	989			
MM		6-147838	May 27, 19	94	Japan (w/English t		

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	1 1- 2000		

^{*} Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.

				Attorn	ey Docket Number	4641-59261								
INFORMATION DISCLOSURE STATEMENT BY APPLICANT AUG 0 8 2003				Application Number Filing Date First Named Inventor Art Unit		09/881,445 June 13, 2001 Ushio 2818								
								Examiner Name		Not yet assigned				
								MA TRADE	MARINO	6-252113	Sept. 9, 199	94	Japan (w/English	translation)
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M		EP 0824995 A1	Feb. 25, 1998		EPC									
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Ms.	. (Ushio et al., "In-situ monitoring of CMP process utilizing 0-order spectrometry," CMP-IMC Conference, pp. 23-29, Feb. 11-12, 1999												
M		Ushio et al., "In-situ monitoring of CMP process utilizing 0-order spectrometry," IMIC Journal on CMP, Vol. 1, No. 1, Fall, 1999												

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EXAMINER SIGNATURE: JULIUM	DATE CONSIDERED: 3-/2-04

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not in conformance and not considered. Send copy.

App: (Unknown) Docket: 4641-59261 INFORMATION DISCLOSURE Applicant: Ushio et al. **STATEMENT** Art Unit: (Unknown) **BY APPLICANT** Filed: June 13, 2001 **U.S. PATENT DOCUMENTS** Filed Class Sub Number Date Name Init.* 8/15/00 Ushio et al. Ш 6,102,775 FOREIGN PATENT DOCUMENTS Sub Country Class Number Date Japan (English Abstract 24.11.98 10311708 Only) OTHER DOCUMENTS DATE my **EXAMINER:** *Examiner: Initial if considered, whether or not in conformance with MPEP 609; draw line through cite if

STATEMENT			Docket: 46	41-59261	App: 09/881,445			
			Applicant:	Applicant: Ushio et al.				
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& TRADENA		U.S. PA	TENT DOCUMI	ENTS				
Init.*	Number	Date	Name		Clas	s Sub	Filed	
		FOREIGN	PATENT DOCU	MENTS	•			
	Number	Date	Country		Class	s Sub		
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MO	JP64-057107	3/3/89	Japan With English Abstract					
M	JP06-252113	9/9/94	Japan With English Abstract					
		OTI	IER DOCUMEN	TS		<u> </u>	-	
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